

Approved for entry IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
7/31/09

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Response Under 37 C.F.R. § 1.116 Expedited Procedure**In re application of:** Kenji Suzuki**Application No.** 10/556,712**Filed:** November 9, 2005**Confirmation No.** 6606**For:** ILLUMINATION OPTICAL SYSTEM,
PROJECTION/EXPOSURE DEVICE,
MICRO DEVICE MANUFACTURING
METHOD, ILLUMINATION DEVICE
MANUFACTURING METHOD,
PROJECTION/EXPOSURE DEVICE
ADJUSTMENT METHOD, AND
PROJECTION/EXPOSURE DEVICE
MANUFACTURING METHOD**Examiner:** Hung Nguyen**Art Unit:** 2851**Attorney Reference No.** 4641-71773-01**FILED VIA EFS
ON JULY 28, 2009**COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450**REPLY TO FINAL OFFICE ACTION, INCLUDING
APPLICANT'S INTERVIEW SUMMARIES**

This paper is submitted in reply to the final Office action dated June 1, 2009.

Remarks begin on page 2.